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CONFIRMATION NO. 3483

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|--|---|---|---|---|--------------------------------|
| SERIAL NUMBER 10/827,512 | FILING OR 371(c) DATE 04/19/2004 RULE | CLASS 134 | GROUP ART UNIT 1709 | ATTORNEY DOCKET NO. 8836-242 (IH13145-US) | |
| APPLICANTS Hun-Jung Yi, Suwon-si, KOREA, REPUBLIC OF; Sang-Oh Park, Yongin-si, KOREA, REPUBLIC OF; | | | | | |
| ** CONTINUING DATA ***** NONE JLN | | | | | |
| ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2003-57249 08/19/2003 JLN | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/29/2004 JLN | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <i>[Signature]</i> JLN Examiner's Signature Initials | | STATE OR COUNTRY KOREA, REPUBLIC OF | SHEETS DRAWING 17 | TOTAL CLAIMS 26 | INDEPENDENT CLAIMS 4 |
| ADDRESS 22150 | | | | | |
| TITLE Apparatus and method for cleaning semiconductor substrates | | | | | |
| FILING FEE RECEIVED 964 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |